

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**APPLICANT:** Min-Hsiung Chiang, et al. **EXAMINER:** Kesha

Keshavan, Belur V.

**SERIAL NO.:** 

09/975,840

**GROUP:** 

2825

FILED:

10/11/2001

**ATTY DKT NO.:** 67,200-547

TITLED:

METHODS AND SYSTEMS FOR FORMING EMBEDDED DRAM

FOR AN MIM CAPACITOR

## **CERTIFICATE OF FACSIMILE**

I hereby certify that this correspondence is being deposited with the U.S. Patent Office via facsimile no. (703) 872-9319 on

100, 25 / /2003.

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## **AMENDMENT AND RESPONSE TO OFFICE ACTION**

Dear Sir:

In response to the Office Action dated September 25, 2003 (Paper No. 4) in the above captioned matter, please enter the following amendments and remarks.

DEC -9 2003
TECHNOLOGY CENTER 2800